

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention

IONIZED PHYSICAL VAPOR DEPOSITION (iPVD) PROCESS

Application Number : 10/811326
Confirmation Number: 9467
First Named Applicant: Frank Cerio
Attorney Docket Number: TAZ259
Art Unit: 1753
Examiner: Steven Versteeg
Search string: (6444099 or 6642146).pn



Certification: This Information Disclosure Statement was submitted under the following conditions, which satisfies the requirement under 37 CFR 1.97(e). The filer certified:

That each item of information contained in the information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	6444099	2002-09-03	Sasaki et al.			
	2	6642146	2003-11-04	Rozbicki et al.			

Remarks

Note: Remarks are not for responding to an office action.

I hereby certify that each item of information contained herein was cited in a communication from a foreign patent office in a counterpart application and that this communication was not received by any individual designated 1.56(c) more than thirty days prior to the filing of this Information Disclosure Statement. (37 C.F.R. 1.704(d))

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Examiner Name	Date